

Abstract

Apparatus, Mold and Method for Producing Substrate for Plasma Display Panel

An apparatus is provided for producing a substrate for PDP, which can easily
5 reduce ununiformity of a dielectric layer and defects of ribs. The apparatus is so
constituted that it comprises:

a table for the plate,

a rib precursor supplying portion for providing a precursor of the ribs on the plate,

a pliable mold having at least groove portions provided in parallel with each other

10 at a fixed distance, which is disposed on the precursor of the ribs provided on the plate,

a mold pressing portion for applying a pressure to the mold, thereby to contact the
mold closely with the plate via the precursor of the ribs, and

a driving portion for moving the mold pressing portion along the groove portions
of the mold.